

<b>Notice of References Cited</b>	Application/Control No. 10/050,570	Applicant(s)/Patent Under Reexamination YAGI ET AL.	
	Examiner Matthew J Song	Art Unit 1765	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,855,254	08-1989	Eshita et al.	117/94
	B	US-6,084,213	07-2000	Kohav et al.	219/390
	C	US-5,759,908	06-1998	Steckl et al.	438/479
	D	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Mogab et al. "Conversion of Si to epitaxial SiC by reaction with C <sub>2</sub> H <sub>2</sub> ", Journal of Applied Physics, Vol 45, No 3, March 1974, pp 1075-1084.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.